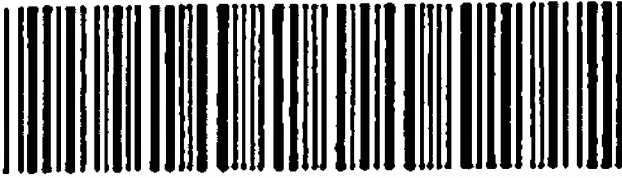


Search Notes 	Application/Control No.		Applicant(s)/Patent under Reexamination	
	10/604,641		PONZIO, MASSIMO	
	Examiner		Art Unit	
	José V. Chen		3637	

SEARCHED			
Class	Subclass	Date	Examiner
100	55.1 55.3 51.11	3/22/06	JVC
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JVC		10/17/06	JVC
JVC		4/16/07	JVC

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
Pa & Base Sources Pa Base Pat	3/22/06	JVC
JVC	10/17/06	JVC
JVC	4/16/07	JVC